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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/751,939	01/02/2001	Jae Goan Jeong	P 275428 2000-OPH-2055	8888
7,7	90 01/15/2002		EXAMI	INER
Pillsbusry Winthrop LLP Intellectual Property Group Ninth Floor, East Tower			VU, DAVID	
1100 New York Avenue, NW Washington, DC 20005-3918			ART UNIT	PAPER NUMBER
			2818	
		DATE MAILED: 01/15/2002		

Please find below and/or attached an Office communication concerning this application or proceeding.

Office A street	Application No.	Applicant(s)
Office A 11 -	00/754 000	
Office Action Summary	09/751,939	JEONG, JAE GOAN
	Examiner DAVID VU	Art Unit
The MAILING DATE of this communic Period for Reply	cation appears on the cover sheet w	2818
A SHORTENED STATUTORY PERIOD FO THE MAILING DATE OF THIS COMMUNIO - Extensions of time may be available under the provisions of after SIX (6) MONTHS from the mailing date of this commu - If the period for reply specified above is less than thirty (30) If NO period for reply is specified above, the maximum state - Failure to reply within the set or extended period for reply w - Any reply received by the Office later than three months after earned patent term adjustment. See 37 CFR 1.704(b). Status	of 37 CFR 1.136(a). In no event, however, may a unication. I days, a reply within the statutory minimum of thi utory period will apply and will expire SIX (6) MOI	reply be timely filed irty (30) days will be considered timely.
1) Responsive to communication(s) file	d on 17 December 2001	
2011 This	b)⊠ This action is non-final.	
3) Since this application is in condition to	for allowance event for the	
3) Since this application is in condition f closed in accordance with the practic	ce under <i>Ex parte Quayle</i> , 1935 C.	itters, prosecution as to the merits is D. 11, 453 O.G. 213
Disposition of Claims		2.000 0.0.210.
4) \boxtimes Claim(s) <u>1-6</u> is/are pending in the app	olication.	
4a) Of the above claim(s) 4-6 is/are wit	thdrawn from consideration.	
5) Claim(s) is/are allowed.		
6)⊠ Claim(s) <u>1-3</u> is/are rejected.		
7) Claim(s) is/are objected to.		
8) Claim(s) are subject to restrictio	on and/or election requirement.	
Application Papers	,	
9)☐ The specification is objected to by the E	xaminer.	
10) The drawing(s) filed on <u>02 January 2007</u>	is/are: a)⊠ accepted or b)□ object	oted to by the Evernines
Applicant may not request that any objecti	ion to the drawing(s) he held in above	non C 07 OFF
The proposed drawing correction filed or	n is: a)□ approved b)□ dis	Sapproved by the Examiner
" approved, corrected drawings are require	ed in reply to this Office action	supplied by the Examiner.
12)∐ The oath or declaration is objected to by	the Examiner.	
riority under 35 U.S.C. §§ 119 and 120		
13) Acknowledgment is made of a claim for	foreign priority under 35 U.S.C. &	119(a)-(d) or (f)
a) \boxtimes All b) \square Some * c) \square None of:	-10.0.3	1.10(a) (a) 01 (i).
1.⊠ Certified copies of the priority doc	suments have been received.	
2. Certified copies of the priority doc	uments have been received in Apr	Olication No.
3. Copies of the certified copies of the	ne priority documents have been re	eceived in this National Stage
14) Acknowledgment is made of a claim for do	Omestic priority under 25 H S.C. S.	ceiveg.
ay in the translation of the foreign language	Te provisional application has been	
, and the state of a cial to to do	omestic priority under 35 U.S.C. 88	ii receiveg. § 120 and/or 121
acimient(s)	2 2 2 2 3 3	, small (21.
Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-9₄ Information Disclosure Statement(s) (PTO-1449) Paper N	. 4) Interview Sun 48) 5) Notice of Info	mmary (PTO-413) Paper No(s) prmal Patent Application (PTO-152)

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DETAILED ACTION

Election/ Restriction

Application's election without traverse of Group I (Claims 1-3) in Paper No.7 is 1. acknowledge.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in-

(1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effect under this subsection of a national application published under section 122(b) only if the international application designating the United States was published under Article 21(2)(a) of such

treaty in the English language; or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that a patent shall not be deemed filed in the United States for the purposes of this subsection based on the filing of an international application filed under the treaty defined in section 351(a).

Claims 1-3 are rejected under 35 U.S.C. 102(e) as being anticipated by Kojima.,(US 2. 6,072,241).

Kojima, in related text (Col. 6, Line. 32-Col. 7, Line. 65) and figures (Fig. 3A-3D) discloses a transistor comprising: a device isolation oxide film formed on a semiconductor substrate, the device isolation oxide including an opening that exposes a portion of the semiconductor substrate, the exposed portion of the semiconductor substrate defining an active region;(Fig. 3H)

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a gate electrode structure formed in the active region, wherein the gate electrode structure covers only a central portion of the active region and is separated from the device isolation oxide film, the gate electrode structure further comprising

a gate oxide film13 formed on the semiconductor substrate in the active region,

a gate electrode formed on the gate oxide film13, the gate electrode having an upper surface and two substantially vertical sidewalls (16a, 17a), the gate electrode further comprising a stacked structure having a first conductor 14a and a second conductor 14b,

an oxide layer 16a formed on the first conductor 14a, and nitride spacers 17a formed on the oxide layer 16a on the sidewalls of the gate electrode;

lightly doped drain (LDD) regions formed in the active region of the semiconductor substrate on both sides of the gate electrode; source/drain regions 22/24 formed in the active region of the semiconductor substrate on both sides of the gate electrode; (Col. 7, Lines. 45-50) and second and third insulating films 25/26 filling and planarizing the space above the active region and between the gate electrode structure and the device isolation oxide film.

In re claim 2, wherein the device isolation oxide film surrounding the opening has substantially vertical profile with respect to the exposed portion of the semiconductor substrate, the profile being modified near the junction of the device isolation oxide film and the semiconductor substrate such that the device isolation oxide film has a substantially rounded profile (Fig. 3D)

In re claim 3, wherein a hard mask layer 15 is formed on the gate electrode (Fig. 3A).

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to David Vu whose telephone number is (703) 305-0391. The examiner can normally be reached on Monday-Friday from 8:00am to 5:00pm.

If attempt to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms., can be reached on (703) 308-4910.

David Vu DV

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Bavid Nelms
Supervisory Patent Examiner
Technology Center 2800